



IFW 1722

PATENT
03345-P0017A WWW/DWA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Michael Heuken, <i>et al.</i>
Application No. 09/873,041	Filing Date: June 1, 2001
Title of Application:	Method And System For Semiconductor Crystal Production With Temperature Management
Confirmation No. 5097	Art Unit: 1722

Mail Stop Issue Fee
Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Notice Of Allowance - Examiner's Detailed Action: Priority

Further to the Examiner's Remarks on Page 2 of the Notice of Allowability re the Certified copy of DE 19855637.3, Applicants respectfully submit that a copy of the priority document is not necessary as it was filed with WIPO.

Respectfully submitted,

July 11, 2006

Wesley W. Whitmyer, Jr., Registration No. 33,558
David W. Aldrich, Registration No. 51,159
Attorneys for Applicants
ST.ONGE STEWARD JOHNSTON & REENS LLC
986 Bedford Street
Stamford, CT 06905-5619
203-324-6155

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July 11, 2006

Beatrice R. Emerson



JFW

URGENT !

Date 7/10/2006

To: Commisioner of patents

Re: Patent office inaction

This is to notify the patent office that I have not heard anything from them for my patent application **11/143048** that was submitted on **June 1, 2005** and verified received by your office stamp on **June 2, 2005**

Please provide status.

Thank You,

Jeff Anderson

P.O. Box 590262

Orlando FL 32859

phone 407-855-8800